

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	21788	438/6,10,104,107,108,109,110,111,112,113,114,118,121,122,123,128,129,135,142,145,149,151,157,176,478,184,193,195,196,197,198,200,201,202,203,206,207,209,210,211,218,237,165,294,308,337,353,378,401,410.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 08:38
S2	182273	"438"/\$.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 08:54
S3	339107	"257"/\$.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 08:54
S4	241489	"29"/\$.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 08:58
S5	640085	S2 or S3 or S4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 08:58
S6	0	S5 and thermopile same detector and infared and semiconductor near3 process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 09:18
S7	21	S5 and thermopile same detector and infrared and semiconductor near3 process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 09:18
S8	60	thermopile same detector and infrared and semiconductor near3 process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 12:46

EAST Search History

S9	30	S8 and infrared same gas same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 12:46
S10	24	S9 and process\$3 same (data or condition or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 09:55
S11	6	(US-20050211555-\$ or US-20050170521-\$ or US-20030175160-\$).did. or (US-6037592-\$ or US-5962854-\$ or US-4816294-\$).did.	US-PGPUB; USPAT	OR	ON	2006/03/13 09:33
S12	6	S11 and process\$3 same (data or condition or parameter) and thermopile same detector and infrared and semiconductor near3 process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 09:46
S13	6	S11 and infrared same gas same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 09:47
S14	3	(US-20050211555-\$).did. or (US-5962854-\$ or US-4816294-\$).did.	US-PGPUB; USPAT	OR	ON	2006/03/13 09:55
S15	3	S14 and process\$3 same (data or condition or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 09:56
S16	3	S14 and process\$3 same (data or condition or parameter) and (control\$4 or computer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 10:02
S17	2	("20040058488").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/03/13 10:02

EAST Search History

S18	2	S17 and process same (system or condition)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 10:02
S19	197	thermopile same detector and infrared and semiconductor and process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 12:46
S20	34	S19 and infrared same gas same (thermopile or detect\$3) and process\$3 same (data or condition or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 12:48
S21	10	S20 xor S10	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 12:48
S22	60	thermopile same detector and infrared and semiconductor near3 process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:19
S23	30	S22 and infrared same gas same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:19
S24	24	S23 and process\$3 same (data or condition or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:19
S25	197	thermopile same detector and infrared and semiconductor and process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:28

EAST Search History

S26	34	S25 and infrared same gas same (thermopile or detect\$3) and process\$3 same (data or condition or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:19
S27	10	S26 xor S24	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:19
S28	10	S27 and (process\$3 or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:10
S29	10	(US-20030139682-\$).did. or (US-6853452-\$ or US-6652468-\$ or US-6540690-\$ or US-5945924-\$ or US-5834777-\$ or US-5747808-\$ or US-5738106-\$ or US-5589689-\$ or US-5444249-\$).did.	US-PGPUB; USPAT	OR	ON	2006/03/13 16:20
S30	10	S29 and (process\$3 or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:20
S31	9	S30 and gas same (temperature or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:11
S32	9	S29 and gas same (temperature or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:11
S33	197	thermopile same detector and infrared and semiconductor and process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 22:15

EAST Search History

S34	198	thermopile same detector and infrared and semiconductor and process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:32
S35	64	S34 and organic	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:36
S37	8	S34 and organic same (filler or epoxy or encapsulant or adhesive)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:43
S38	61	thermopile same detector and infrared and semiconductor near3 process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:38
S39	31	S38 and infrared same gas same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:38
S40	25	S39 and process\$3 same (data or condition or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:38
S41	198	thermopile same detector and infrared and semiconductor and process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:38
S42	35	S41 and infrared same gas same (thermopile or detect\$3) and process\$3 same (data or condition or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:38

EAST Search History

S43	10	S42 xor S40	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:38
S44	0	S43 and organic same (filler or epoxy or encapsulant or adhesive)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:39
S45	0	S43 and organic	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:40
S46	7	S40 and organic	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:40
S47	7	(US-20050211555-\$ or US-20050214167-\$ or US-20030175160-\$ or US-20050153435-\$ or US-20050170521-\$ or US-20040058488-\$).did. or (US-6444474-\$).did.	US-PGPUB; USPAT	OR	ON	2006/03/14 16:40
S49	7	S47 and organic	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:41
S50	17	organic same (filler or epoxy or encapsulant or adhesive or solvent) and thermopile same detector and infrared and semiconductor near3 process\$3 and (wavelength or spectrum or frequency) same (thermopile or detect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 16:44
S51	10	(US-20030139682-\$).did. or (US-6853452-\$ or US-6652468-\$ or US-6540690-\$ or US-5945924-\$ or US-5834777-\$ or US-5747808-\$ or US-5738106-\$ or US-5589689-\$ or US-5444249-\$).did.	US-PGPUB; USPAT	OR	ON	2006/03/14 17:20

EAST Search History

S52	9	S51 and gas same (temperature or parameter)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 17:20
S53	7	S51 and react\$4	US-PGPUB; USPAT	OR	ON	2006/03/14 17:21
S54	182356	"438"/\$.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 17:45
S55	27066	S54 and dry near3 etch\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 17:46
S56	2284	S55 and organic same (layer or surface) and ("o.sub.2" or oxygen) same etch\$4 and conduct\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 17:48
S57	938	S56 and organic same conduct\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 17:50
S58	4	S57 and ole	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 17:49
S59	47	S57 and oled	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 17:49

EAST Search History

S60	47	(US-20030071303-\$ or US-20040164296-\$ or US-20020104995-\$ or US-20030207500-\$ or US-20060003498-\$ or US-20050233507-\$ or US-20050164434-\$ or US-20050079656-\$ or US-20010026835-\$ or US-20030104659-\$ or US-20050181551-\$ or US-20050095761-\$ or US-20030232468-\$ or US-20030082859-\$ or US-20020187594-\$ or US-20060051914-\$ or US-20050181526-\$ or US-20030224547-\$ or US-20040101988-\$ or US-20030082889-\$ or US-20040224486-\$ or US-20050020037-\$ or US-20020182828-\$ or US-20050112850-\$ or US-20050250308-\$ or US-20050112881-\$).did. or (US-20010049197-\$ or US-20060035469-\$ or US-20030194882-\$ or US-20050019977-\$ or US-20040009627-\$).did. or (US-6719916-\$ or US-6911667-\$ or US-6541790-\$ or US-6946330-\$ or US-6872604-\$ or US-6984550-\$ or US-6872607-\$ or US-6855584-\$ or US-6821828-\$ or US-6881598-\$ or US-6949389-\$ or US-6566156-\$ or US-6743700-\$ or US-6872658-\$ or US-6949468-\$ or US-6953705-\$). did.	US-PGPUB; USPAT	OR	ON	2006/03/14 17:50
S61	47	S60 and organic same conduct\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/14 17:50